

00684.103076

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: M. Liu
Natsuhiko MIZUTANI)	
	:	Group Art Unit: 2851
Application No.: 10/529,893)	
	:	Confirmation No.: 7796
35 U.S.C. § 371(c))	
Completion Date: October 17, 2005	:	
)	August 15, 2007
For: NEAR-FIELD EXPOSURE METHOD AND	:	
APPARATUS, NEAR-FIELD EXPOSURE)	
MASK, AND DEVICE MANUFACTURING	:	
METHOD)	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT & SUBMISSION OF
SUBSTITUTE SPECIFICATION

Sir:

In response to the Official Action dated July 10, 2007, please amend the above-identified application as follows: